

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jung et al.

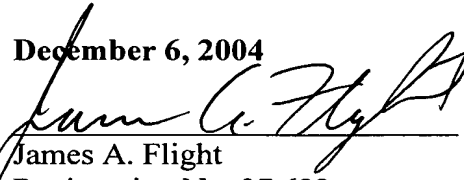
Serial No.: 10/722,312

For: METHODS OF
MANUFACTURING A
SEMICONDUCTOR DEVICE

Filed: November 25, 2003

Group Art Unit: 2812

Examiner: Lynne Ann Gurley

) I hereby certify that this paper is
) being deposited with the United
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) mail, postage prepaid, in an
) envelope addressed to:
) Commissioner for Patents
) P.O. Box 1450
) Alexandria, VA 22313-1450, on
) this date:
) **December 6, 2004**
) 
) James A. Flight
) Registration No. 37,622
) Attorney for Applicants

RESPONSE TO THE OFFICE ACTION DATED AUGUST 6, 2004

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated August 6, 2004, please enter the following amendments and consider the following remarks:

The Amendments to the Specification begin on page 2 of this paper.

The Status of the Claims is reflected in the listing of claims that begins on page 5 of this paper.

Remarks begin on page 8 of this paper.

